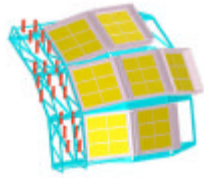


Thin Film coating

Development of CsI photocathodes

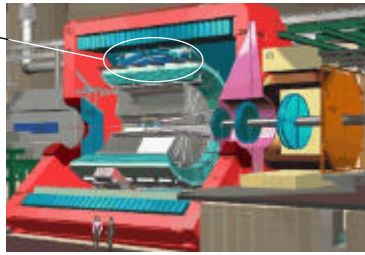
ALICE HMPID/RICH:

for Ring Imaging CHerenkov detectors

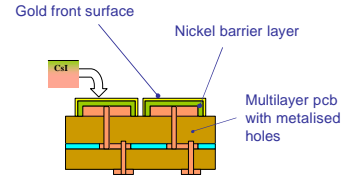
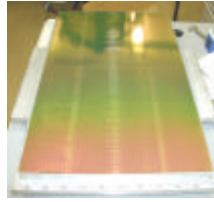


7 photodetectors modules each with 6 CsI PCs.

Total area 12 m²

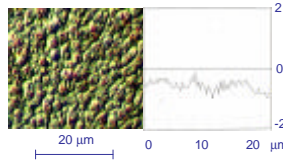


Photocathodes: Modules of 64 x 45 cm²:

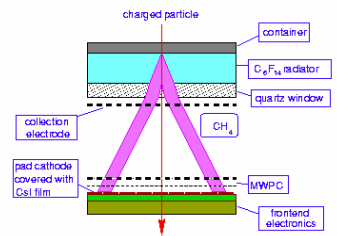


CsI substrate:

standard printed circuit board



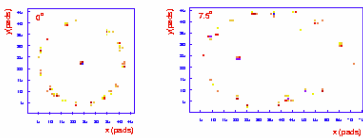
- Ni and Au barrier layers on top of Cu pads (~8x8 mm²)
- Standard Electro-plating technology



A proximity focusing RICH detector for High Momentum Particle Identification

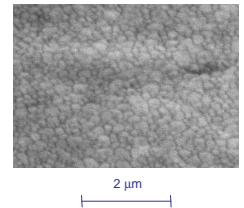
Photon detector:

MWPC with CH₄ at atmospheric pressure in front of a CsI thin film reflective photocathode



CsI thin film:

300nm thick, obtained by Physical Vapour Deposition process



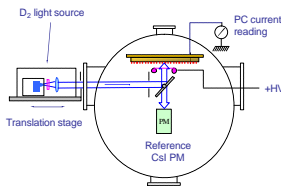
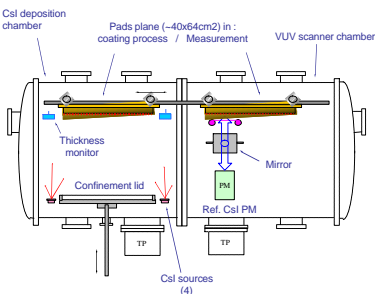
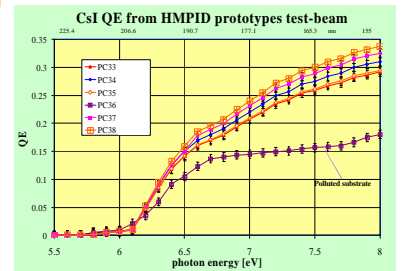
Coating plant developed at CERN:

- Processing photocathode modules up to 60 x 60 cm²
- Transfer facility of CsI films under inert gas
- In situ CsI QE evaluation under vacuum

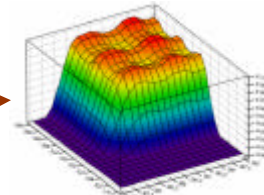


Performances:

- High QE obtained from RD26 output
- ~ 20 photoelectrons (per cm of radiator) currently detected in a single event

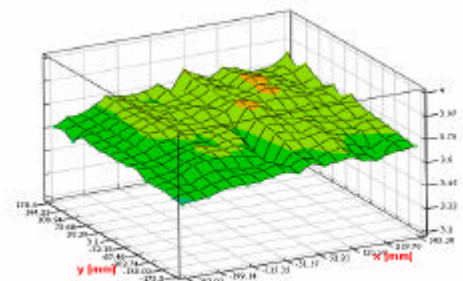


- Photocurrent scan over the whole PC area
- Gives relative photocurrent from integral illumination



- High sensitivity of VUV scanner monitoring

- Uniform response over large area



Final series production (50 PCs) started May 2004 with a production rate of 1 PC/week